

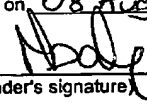
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Attorney Docket No. 100176)

First Inventor: Roland K. Sevilla
Serial No.: 10/601,601
Filing Date: 06/23/2003
Title: POLISHING PAD FOR
ELECTROCHEMICAL-
MECHANICAL POLISHING
Examiner: Maurina T. Rachuba
Art Unit: 3723

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RESPONSE UNDER 37 CFR 1.114(c)

This is a reply to the Office Communication mailed July 5, 2006 for the above captioned U.S. patent application.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

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